



1765  
[10191/2169]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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Applicant(s) : BECKER et al. Confirmation No.: 8531  
Serial No. : 10/031,842  
Filed : June 10, 2002  
For : DEVICE AND METHOD FOR ETCHING A SUBSTRATE  
BY USING AN INDUCTIVELY COUPLED PLASMA  
Examiner : S. Ahmed  
Art Unit : 1765  
Customer No. : 26646

I hereby certify that this correspondence is being deposited with  
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Date 11/24/03 Atty's Reg. # 41,172

Atty's Signature

*LB Magist*  
DERVIS MAGISTRE  
KENYON & KENYON

Non-Fee Amendment  
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**ELECTION TRANSMITTAL**

SIR:

Please find herewith an Election With Traverse for filing in the  
above-identified patent application.

No fee is believed to be required. However, if any fee is required, please  
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Respectfully submitted,

KENYON & KENYON

By: *LB Magist* (Reg. No. 41,172)

Dated: 11/24/03

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